

**Notice of References Cited**

Application/Control No.

10/577,780

Applicant(s)/Patent Under  
Reexamination  
NAGAI ET AL.

Examiner

Eva Montalvo

Art Unit

2814

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0168664	09-2003	Hahn et al.	257/79
*	B	US-6,501,102	12-2002	Mueller-Mach et al.	257/84
*	C	US-6,562,643	05-2003	Chen, Hsing	438/26
*	D	US-5,278,432	01-1994	Ignatius et al.	257/88
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
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	X	

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